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Deposit Date May 14, 2001

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Applicants: Nick J. Huige et al.  
Serial No.: 09/448,578  
Filed: November 23, 1999  
For: METHOD OF OXYGENATING YEAST SLURRY USING  
HYDROPHOBIC POLYMERIC MEMBRANES  
Group Art: 1761  
Examiner: C. Sherrer

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
Washington, D.C. 20231

Sir:

The enclosed documents are being submitted in compliance with 37 C.F.R. 1.97 and 1.98. A form "Information Disclosure Statement by Applicant" is attached which lists the references cited and copies of the references are enclosed herewith.

Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement. A copy of the PCT International Search Report citing these references is also enclosed.

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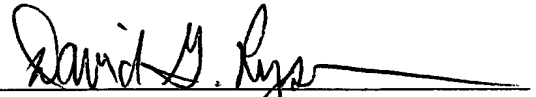
No fee is believed to be necessary. However, should a fee be deemed due by the Director, such fee should be charged to Deposit Account No. 17-0055.

Respectfully submitted,

Nick J. Huige, et al.

Dated: May 14, 2001

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